



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:

M. TANAKA et al.

Serial No.:

09/942,213

Filed:

August 30, 2001

For:

METHOD AND APPARATUS FOR INSPECTING A

SEMICONDUCTOR DEVICE

Art Unit:

2812

Examiner:

Not Yet Docketed

SUBMISSION OF REPLACEMENT DECLARATION

Assistant Commissioner for Patents Washington, D.C. 20231

April 10, 2003

Sir:

Attached hereto is a replacement declaration for the above-identified application which <u>replaces</u> the declaration filed on October 15, 2001, in the present application in response to the Notice to File Missing Parts of Nonprovisional Application of October 9, 2001.

The declaration filed on October 15, 2001, in the present application is actually for application Serial No. 09/942,862 filed on August 31, 2001, which is a divisional application of the present application.

The declaration attached hereto for the present application is identical to the declaration filed on October 15, 2001, in the present application which is actually for divisional application 09/942,862 except that page 1 of the

declaration attached hereto for the present application lists the title "Method and Apparatus for Inspecting a Semiconductor Device" of the present application which appears on page 1 of the original specification of the present application, while page 1 of the declaration filed on October 15, 2001, in the present application which is actually for divisional application Serial No. 09/942,862 lists the original title "A Method of Fabricating a Semiconductor Device" of divisional application Serial No. 09/942,862.

Both the declaration attached hereto for the present application and the declaration filed on October 15, 2001, in the present application which is actually for divisional application 09/942,862 consist of four pages erroneously numbered "Page 1 of 5", "Page 2 of 5", Page 3 of 5", and "Page 4 of 5".

These four pages should have been numbered "Page 1 of 4", "Page 2 of 4", Page 3 of 4", and "Page 4 of 4" because both of the declarations consist of only four pages, and were never intended to include a Page 5.

The original specification (except for the title, the first paragraph, and the claims) and the original drawings of the present application are identical to the original specification (except for the title, the first paragraph, and the claims) and the original drawings of divisional application Serial No. 09/942,862.

It is respectfully requested that the declaration attached hereto for the present application be placed in the file of the present application.

Respectfully submitted,

ANTONELLI, TERRY, STOUT & KRAUS, LLP

Hung H. Bui

Registration No. 40,415

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Attachment



Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it displays a valid OMB control number

下記の氏名の発明者として、私は以下の通り宣言します。	As a below named inventor, I hereby declare that:
私の住所、私書籍、国籍は下記の私の氏名の後に記載された通りです。	My residence; post office address and citizenship are as stated next to my name.
下記の名称の発明に関して請求範囲に記載され、特許出願している発明内容について、私が最初かつ唯一の発明者(下記の氏名が一つの場合)もしくは最初かつ共同発明者であると(下記の名称が複数の場合)信じています。	I believe I am the original, first and sole inventor (if only one name is listed below) or an original, first and joint inventor (if plural names are listed below) of the subject matter which is claimed and for which a patent is sought on the invention entitled
	Method and Apparatus for Inspecting a Semiconductor Device
上記発明の明細書(下記の欄で×印がついていない場合は、 本書に添付)は、	The specification of which is attached hereto unless the following box is checked:
□月_日に提出され、米国出願番号または特許協定条約 国際出願番号をとし、 (該当する場合)に訂正されました。	was filed on as United States Application Number or PCT International Application Number and was amended on (if applicable).
私は、特許請求範囲を含む上記訂正後の明細書を検討し、内容を理解していることをここに表明します。	I hereby state that I have reviewed and understand the contents of the above identified specification, including the claims, as amended by any amendment referred to above.
私は、連邦規則法典第37編第1条56項に定義されるとおり、特許資格の有無について重要な情報を開示する義務があることを認めます。	I acknowledge the duty to disclose information which is material to patentability as defined in Title 37, Code of Federal Regulations, Section 1.56.

I hereby claim foreign priority under Title 35, United States Code,

Section 119 (a)-(d) or 365(b) of any foreign application(s) for

patent or inventor's certificate, or 365(a) of any PCT international

application which designated at least one country other than the

United States, listed below and have also identified below, by

checking the box, any foreign application for patent or inventor's

certificate, or PCT International application having a filing date before that of the application on which priority is claimed.

Japanese Language Declaration (日本語宣言書)

私は、米国法典第35編119条 (a) - (d) 項又は365条 (b) 項に基き下記の、米国以外の国の少なくとも一カ国を指定している特許協力条約365 (a) 項に基ずく国際出願、又は外国での特許出願もしくは発明者証の出願についての外国優先権をここに主張するとともに、優先権を主張している、本出願の前に出願された特許または発明者証の外国出願を以下に、枠内をマークすることで、示している。

Priority Not Claimed Prior Foreign Application(s) 外国での先行出願 優先権主張なし 20/June/2001 2001-185773 **Japan** (Number) (Country) (Day/Month/Year Filed) (出願年月日) (番号) (国名) П (Day/Month/Year Filed) (Number) (Country) (出願年月日) (番号) (国名) 私は、第35編米国法典119条 (e) 項に基いて下記の米国 I hereby claim the benefit under Title 35, United States Code, 特許出願規定に記載された権利をここに主張いたします。 Section 119(e) of any United States provisional application(s) listed below. (Filing Date) (Application No.) (Filing Date) (Application No.) (出願番号) (出願日) (出願番号) (出願日)

私は、下記の米国法典第35編120条に基いて下記の米国特許出願に記載された権利、又は米国を指定している特許協力条約365条 (c) に基ずく権利をここに主張します。また、本出願の各請求範囲の内容が米国法典第35編112条第1項又は特許協力条約で規定された方法で先行する米国特許出願に開示されていない限り、その先行米国出願書提出日以降で本出願書の日本国内または特許協力条約国際提出日までの期間中に入手された、連邦規則法典第37編1条56項で定義された特許資格の有無に関する重要な情報について開示義務があることを認識しています。

any PCT international application designating the United States, listed below and, insofar as the subject matter of each of the claims of this application is not disclosed in the prior United States or PCT International application in the manner provided by the first paragraph of Title 35, United States Code Section 112, I acknowledge the duty to disclose information which is material to patentability as defined in Title 37, Code of Federal Regulations, Section 1.56 which became available between the filing date of the prior application and the national or PCT international filing date of application.

I hereby claim the benefit under Title 35, United States Code,

Section 120 of any United States application(s), or 365(c) of

(Application No.)
(出願番号)(Filing Date)
(出願日)(Status: Patented, Pending, Abandoned)
(現況:特許許可済、係属中、放棄済)(Application No.)
(出願番号)(Filing Date)
(出願日)(Status: Patented, Pending, Abandoned)
(現況:特許許可済、係属中、放棄済)

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Japanese Language Declaration (日本語宣言書)

委任状: 私は下記の発明者として、本出願に関する一切の手 続きを米特許商標局に対して遂行する弁理士または代理人と して、下記の者を指名いたします。(弁護士、または代理人の 氏名及び登録番号を明記のこと)

POWER OF ATTORNEY: As a named inventor, I hereby

appoint the following attorney(s) and/or agent(s) to prosecute this application and transact all business in the Patent and Trademark Office connected therewith (list name and registration number)

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(第二以降の共同発明者についても同様に記載し、署名をする こと) (Supply similar information and signature for second and subsequent joint inventors.)

(Supply similar information and signature for sixth and

subsequent joint inventors.)

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こと)